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09/890550 DF	438- 42 8	364.4	2812	177/ 75	
Kazutaka Majima Hiroyuki Yasuda					
TAGS					
Porous silicon carbide sintered compact and silicon carbide metal					
composite suitable for use in table for wafer polishing machine					
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ISSUING CLASSIFICATION					
ORIGINAL	CROSS REFERENCE				
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TERMINAL DISCLAIMER	DRAWINGS		CLAIMS ALLOWED		
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
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The term of this patent shall			(===,		
not extend beyond the expiration date					
of U.S Patent. No				ISSUE FEE	
				Amount Due	Date Paid
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The terminalmonths of his patent have been disclaimed.					
VARNING:	(Legsi Instrumen	ts Examiner)	(Date)	<u> </u>	
he information disclosed herein may be re					i, Sections 122, 181 and 368.
ossession outside the U.S. Patent & Trade	mark Unice is restricted to				JEICHE DOD BOM

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